MUETING & RAASCH

JAN 2 2 2004

OFFICIAL
PATENT
Docket No. 150.00560102

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):	Lee et al.	) Group Art Unit:	1765
Serial No.: Confirmation	09/560,268 No.: 2517	) Examiner: )	Duy Deo
Filed:	April 26, 2000	, ) )	·
For:	COMPOSITIONS FOR SELF SILICIDE (As Amended)	ECTIVELY ETCHING AGA	INST COBALT

## RESPONSE

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

The following is provided in response to the Office Action mailed October 22, 2003. Remarks begin on the page entitled "Remarks."

PAGE 2/10\* RCVD AT 1/22/2004 2:59:49 PM [Eastern Standard Time] \* SVR:USPTO-EFXRF-1/7\* DNIS:8729306\* CSID:1 612 305 1228\* DURATION (mm-ss):03-50

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